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ATTORNEY DOCKET NO: APPLICATION NO: 09/375,169 26767-1000 INFORMATION DISCLOSURE STATEMENT (37 C.F.R. 1.56, 1.97, and 1.98) APPLICANTS: C. Aita et al. FILING DATE: SHEET 2 OF 7 **GROUP** August 16, 1999 OTHER DOCUMENTS † EX'R INITIAL REF. # CITATION (Author, Article Title, Journal/Book Title, Date, Pertinent Pages, etc.) H.E. Kambic, 'Changing strategies for biomaterials and biotechnology', in Biomaterials' Mechanical CA Properties, ASTM STP 1173 (edited by H.E. Kambic and A.T. Yokobori, Jr., American Society for Testing Materials, Philadelphia, PA, 1994) pp. 293-301. O.F. Bertrand, R. Mongrain, J. Rodes, J.C. Tardif, L. Bilodeau, G. Cote, and M. Bourassa, 'Biocompatibility aspects of new stent technology', Journal of the American College of Cardiology 32, 562-571 (1998). B. Kasemo and J. Lausmaa, 'Surface properties and process of the biomaterial-tissue interface', CC Materials Science and Engineering CI, 115-119 (1994). S.H. Teoh, S.C. Lim, E.T. Yoon, and K.S. Goh, 'A new method for in-vitro wear assessment of materials used in mechanical heart valves', in Biomaterials' Mechanical Properties, ASTM STP 1173 (Edited by H.E. Kambic and A.T. Yakabori, Jr., American Society for Testing and Materials, Philadelphia, PA 1994) pp. 43-52. R. Hauert, U. Müller, G. Francz, F. Birchler, A. Schroeder, J. Mayer, and E. Wintermantel, 'Surface analysis and bioreactions of F and Si containing a-C:H', Thin Solid Films 308-309, 191-194 (1997). M. Shirkhanzadeh, 'Nanopourous alkoxy-derived titanium oxide coating: a reactive overlayer for CF functionalizing titanium surface', Journal of Materials Science: Materials in Medicine 9, 355-362 (1998).CG M. Amon, A. Bolz, and M. Schaldach, 'Improvement of stenting therapy with a silicon carbide coated tantalum stent', Journal of Materials Science: Materials in Medicine 7, 273-278 (1996). CH L.D. Piveteau, M.J. Girona, L. Schlapbach, P. Barboux, J.P. Bailot, and B. Gasser, 'Thin films of calcium phosphate and titanium dioxide by a sol-gel route: a new method for coating medical implants', Journal of Materials Science: Materials in Medicine 10, 161-167 (1999). **EXAMINER'S SIGNATURE** DATE CONSIDERED

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INFORMATION DISCLOSURE STATEMENT

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	ATTORNEY DOCKET NO: 59 26767-1000	APPLICATION NO: 09/375769
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	FILING DATE: August 16, 1999	GROUP: 0775

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